New Magnetron Design Improves Sputtering Material Utilization from 14% to 40%

Reactive NanoTechnologies, Inc.'s (RNT) NanoFoil® foil precisely controls the instantaneous release of heat energy for advanced bonding applications such as soldering electronic components that cannot withstand the high temperatures of a reflow oven. When RNT first began producing this product, costs were relatively high because the original process utilized only 14% of the relatively expensive nickel sputtering targets. RNT's magnetron supplier, Angstrom Sciences, Duquesne, Pennsylvania, developed a custom magnetron which optimized the magnetic fields that more fully utilizes the target. "The new magnetron nearly triples the material utilization of our nickel targets to 40%, enabling a significant reduction in our overall manufacturing costs," said Frank Zimone, Vice President of Operations of RNT, which is based in Hunt Valley, Maryland. "The reduction in our manufacturing costs enables us to compete much more effectively as an alternative to solder reflow and other bonding methods."

Reflow oven too hot for some components

As electronic components become faster and more capable, they generate increased amounts of heat that must be conducted to ambient to avoid failure. The most efficient way to conduct heat is through a metallic bond such as solder. But many important components such as light emitting diodes (LEDs), transformers, Voltage Controlled Crystal Oscillators (VCXOs), etc. cannot withstand the 250°C temperatures used to solder components in a reflow oven. The advent of Reduction of Hazardous Substances (RoHS) regulations complicates the problem even further because the lead-free solders needed to comply with these regulations require higher temperatures than those used in the past. Also, the increased requirements for better thermal transfer, due to much tighter packaging at the component, circuit board, and system level, have led electronic manufacturers to look for solutions beyond standard thermal adhesives, grease and tapes.



Figure 1: When NanoFoil® is activated, the temperature in the reaction region (white area) reaches 1,500°C while propagating at a rate of 6-10 meters per second.

NanoFoil® addresses these challenges by creating a strong, thermally conductive bond between a heat sink and a chip without raising the temperature of the chip. NanoFoil® is fabricated by vapor-depositing thousands of alternating nanoscale layers of aluminum and nickel on a substrate. The resulting foil is placed between the heat sink and the chip or other components to be bonded. When activated by a small pulse of energy, the foil reacts to deliver localized heat up to temperatures of 1500°C in fractions of a second while propagating at a rate of 6-10 meters per second. NanoFoil® can be used to bond metals, ceramics, semiconductors and certain polymers. The bonding process allows freedom in the choice of solders and is flux-free, eliminating a cleaning operation.

Sputtering used to produce foil

RNT produces NanoFoil® by alternately sputtering or depositing nickel and aluminum atom by atom onto a substrate. The sputtering process takes place in a vacuum chamber that contains the target consisting of the material to be deposited as well as the substrate. Argon is introduced into the chamber and ionized. A magnetron utilizes strong magnetic fields to trap electrons close to the surface of the target. The positively charged argon ions accelerate towards the target and strike it with sufficient force to remove material. The sputtered ions ballistically fly from the target and impact energetically on the substrate. After the foil has been built up onto the substrate, it is peeled off to produce the final product. The target material can be limited by inevitable non-uniformities in the magnetic field or poor magnetic design.

"Our production startup was trouble-free enabling us to focus our energies on working with customers to develop applications for NanoFoil®," Zimone said. But RNT soon determined that they needed to reduce the costs of manufacturing the foil in order to be profitable at pricing levels that would keep the new technology competitive with alternative bonding methods. The most obvious potential area for cost-reduction was improving the utilization of the nickel target. The utilization of this target is important because the nickel target costs much more than the aluminum target and the cost of the nickel target per unit of nickel is several times the scrap value that can be obtained from the depleted target. "I worked with Angstrom Sciences magnetrons while I was at several different companies and have a great deal of confidence in Angstrom's ability to design custom magnetrons to meet special requirements," Zimone said. "We shipped the magnetron that we used on our development tool to Angstrom Sciences and asked them if they could improve its utilization. It was also important to ensure that the any changes made to the magnetron did not affect the high levels of quality that we were achieving with the original magnetron."

Simulation used to improve target utilization

"The critical factor affecting the utilization of the target in a magnetron is the distribution of the magnetic field used to trap electrons above the target," said Richard Newcomb, Research and Development Manager for Angstrom Sciences. The region and depth of the target erosion generally mirrors the shape of the magnetic field lines one half to one inch about the surface of the target. This is because the electrons that create the discharge are accelerated around the target at approximately 90 degree angle relative to the magnetic field lines. By tuning the intensity and shape of the magnetic field, the electrons can be allowed to travel in a broad path which will ultimately lead to utilizing more of the available target surface and better uniform of thin film coatings.



Existing RNT Design



Proposed New Design

Figure 2: Electromagnetic simulation of existing magnetron and new magnetron designs shows that field lines just above target are considerably flatter with the new design

Newcomb used electromagnetic simulation in an effort to optimize the magnetic fields around the target in order to improve its utilization. Simulation is attractive because it enables engineers to determine the performance of a design before it is built. Engineers can quickly try out different designs in their attempt to achieve effective containment while minimizing costs. Newcomb defined the geometry of the original magnetron, entered materials properties for the components and defined the currents and conductivities. A major advantage of electromagnetic simulation is that Newcomb was able to view the direction and magnitude of electromagnetic fields throughout the area of interest around the target. This helped provide an understanding of how the fields needed to be modified which in turn helped determine what changes in geometry and materials

could improve the design. Each design iteration provides more understanding of the sensitivity of the magnetic field to changes in geometry and materials. Physically it is impossible to achieve the flat field lines across the target surface that would provide near-total target utilization. But Newcomb was able to considerably flatten the field lines by changing the geometry of the magnets.



Figure 3: Graph shows the magnitude of the normal (Bn) and tangent (Bt) magnetic fields across the width of the target at a height of ¹/₂ inch above the target

Figure 3 graphs the magnetic fields of the old and new magnetrons along a line running across the width of the target one-half inch above the surface of the target. "An ideal magnetic field would confine the electrons around the entire target with fields in the shape of a structure with walls consisting of the normal field and a roof consisting of the tangential field," Newcomb said. "Of course, it's physically impossible to achieve this goal in a real-world magnetron but our design objective is to come as close as possible." Field 3 shows that in the original design the width of the negative tangential field (blue line) is about 1.5 inches while in the new design the width of the negative tangential field (red line) is about 2.25 inches. The figure also

shows that the slope of the normal field in the new design is only about half the value of the slope in the original design. The reduced slope reduces the slope of the erosion pattern in the target which results in more material being utilized.



Figure 4: Erosion profile of target in old magnetron shown on left and erosion profile of target in new magnetron shown on right

The comparison of the erosion profiles of the target in the old and new magnetrons shows how improving the magnetic field substantially improves the target utilization. The grooves in the target on the right have a much shallower slope, indicating that substantially more material was removed before the target was depleted. "The new magnetron increased our target utilization to 40% which in turn reduced our manufacturing costs significantly," Zimone concluded. "This improvement in our cost structure makes it possible to earn a profit while selling NanoFoil® at market prices. This improvement has helped transform NanoFoil® from a technical curiosity to a competitive product that is having a major impact in the marketplace."